# Shape transition in the epitaxial growth of gold silicide in Au thin In son Si(111)

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## Abstract

G row th of epitaxial gold silicide islands on brom ine-passivated Si(111) substrates has been studied by optical and electron m icroscopy, electron probe m icro analysis and helium ion backscattering. The islands grow in the shape of equilateral triangles up to a critical size beyond which the symmetry of the structure is broken, resulting in a shape transition from triangle to trapezoid. The island edges are aligned along S i[110] directions. W e have observed elongated islands with aspect ratios as large as 8:1. These islands, instead of grow ing along three equivalent [110] directions on the Si(111) substrate, grow only along one preferential direction. This has been attributed to the vicinality of the substrate surface.

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Heteroepitaxy produces strained epitaxial layers due to lattice m ism atch between the substrate and the overlayer. Strained epitaxial layers have interesting properties and are important in sem iconductor devices [1]. Since these layers are inherently unstable it is important to understand the mechanism of relaxation of strain. It has been known for a long time that the form ation of dislocations is a strain relief mechanism [2,3]. However, in recent years it has been recognized that strained layers are unstable against shape changes [4]. Thus shape changes, such as island form ation, have been identied as a majorm echanism for strain relief. Recently Terso and Trom p [5] have shown that strained epitaxial islands, as they grow in size, may undergo a shape transition. Below a critical size, islands have a com pact symmetric shape. But at larger sizes, they adopt a long thin shape, which allows better elastic relaxation of the island stress. They observed such elongated island growth of A g on Si(001) surface. P rior to this, various other groups also observed elongated island growth of Ge on Si(001) [6], Au on Ag (110) [7], Au on M o (111) and on Si(111) [8] and G aAs islands on Si [9]. In all the aforem entioned cases where the elongated island growth was observed, the deposition was performed under ultrahigh vacuum (UHV) condition in the submonolayer to a few monolayers range and on atom ically clean substrates.

Here we present our observation of the growth of large epitaxial gold silicide islands on Si(111) substrates in a non-UHV m ethod. M oreover, the epitaxial structures were obtained from a relatively thick (1000 A) In deposited uniform ly on the substrate. A fler annealing, we have observed growth of small equilateral triangular silicide islands recting the threefold symmetry of the underlying Si(111) substrate. The size of these triangular islands grow up to a critical size beyond which there is a transition to a trapezoidal shape. The trapezoidal islands have varying lengths, but similar widths. The largest of the islands have an aspect ratio of about 8:1. The main observed features are in reasonable agreement with the prediction of the recent theory of shape transition by Terso and Trom p [5]. How ever, in this theory dislocation-free strained islands have been considered. We not evidence for dislocations in the silicide islands as well. Thus, to our know ledge, we report for the rest time the evidence for both the strain relief mechanism s, namely, the shape transition and

the form ation of dislocations in the sam e system . A nother interesting feature of our observations is that all the elongated islands are aligned in the sam e direction, although one would expect them to grow in three di erent orientations in posed by the threefold sym m etry of the Si(111) substrate surface. This additional sym m etry-breaking in the grow th of epitaxial islands has been attributed to the vicinality of the substrate surface.

The method of sample preparation involves gold evaporation onto a brom ine-passivated Si(111) water (n-type, Sb-doped, 0.005-0.02 on ) substrate and subsequent annealing. The method used for the brom ine passivation of the Si(111) surface is known to provide Br adsorption (1=4 m onolayer) at the atop site on the surface Si dangling bonds on hydro uoric acid-etched [10] or cleaved [11] Si(111) surfaces. Br adsorption inhibits the surface oxidation process. A detailed x-ray photoelectron spectroscopic characterization of the Br-treated Si surfaces has been published elsewhere [12]. It was also shown that a Cu thin In deposited on a Br-passivated Si(111) surface has interdi usion behavior very similar to the case where Cu was deposited on an atom ically clean (7 7) reconstructed Si(111) surface [13,14]. It should be noted that chem ically prepared B r-passivated Si(111) surface in open air [10] and Br-adsorbed atom ically clean Si(111) surface under ultrahigh vacuum condition [15] show identical behaviour regarding Br-adsorption site, Si Br bond length, substrate surface relaxation etc. Also the presence of some impurities on the Si substrate prior to metal deposition is not an impediment for epitaxial silicide growth. In this case the concept of self-cleaning interface has been discussed by Lau and M ayer [16]. Epitaxial growth on B r-passivated substrate assumes further in portance in the light of the recent spurt of activities on in purity (surfactant)-controlled epitaxial growth [17]. In the present work a 1200 A thin Au Im was evaporated from a W basket onto a Br-passivated Si(111) substrate at room temperature in high vacuum (10  $^{6}$  Torr). Then the sample was annealed at  $(360 \ 10)^{\circ}$ C, that is around the Au Si eutectic tem perature of 363°C [18], for 20 m inutes in high vacuum. This gave rise to the triangular and trapezoidal island structures shown in Fig. 1 and Fig. 2. The triangular islands have strong sim ilarities with the growth of (7 7) reconstructed triangular dom ain growth on an atom ically clean Si(111)

surface in the low temperature phase of the  $(7 \ 7)$  \$  $(1 \ 1)$  order-disorder transition [19]. We also observed fractal structures of Au for this system which will be presented elsewhere [20]. Longer (50 m in and 80 m in) annealing, though changes the Au fractal structure, does not have any signi cant e ect on the large silicide island structures.

In Fig. 1, we notice the form ation of the equilateral triangular structure re ecting the three-fold symmetry of the Si(111) surface. This indicates that these triangular islands are crystalline epitaxially grown on the substrate. The composition of the triangular structures, as determ ined from electron probe micro analysis (EPMA), is  $Au_4Si$  [actually 3)% Au, (21 3)% Si for both triangular and trapezoidal islands]. Here we observe (79 equilateral triangles of alm ost identical size. The edges of the equilateral triangles are aligned along substrate [110] directions. This alignment has also been observed for silicide growth on a Si(111) surface under UHV condition [8] as well as for gold silicide precipitates in the bulk [21]. In Fig. 2, we observe som e equilateral triangular islands which have grown larger, but mostly we notice islands of trapezoidal shape with larger areas than that of the triangles. The widths of all the trapezoidal islands are comparable and are roughly equal to the width of the largest equilateral triangular island. That is, grow th of the islands beyond a critical size, represented by the largest triangular island, is associated with the shape transition: triangle to trapezoid.

W e will discuss our results in the light of the recent theory given by Terso and Trom p [5], who treated the case of G e grow th on Si(100) as a generic case. For a strained island on a substrate they computed the energy of an island as a sum of two contributions one from the relevant surface and interface energies and the other from elastic relaxation. The surface energies are those of the substrate and of the island top and edge facets, and the interface energy is that for the island-substrate interface. The second contribution arises from the fact that an island under stress exerts a force on the substrate surface, which elastically distorts the substrate. This lowers the energy of the island at the cost of some strain in the substrate. Terso and Trom p derived an expression for the energy per unit volum e (E/V) of a rectangular strained epitaxial island :

$$\frac{E}{V} = 2 (s^{1} + t^{1}) 2ch [s^{1} ln [\frac{s}{h}] + t^{1} ln [\frac{t}{h}]]$$
(1)

where s, t and h are width, length and height of the island, respectively; =  $e^{3-2} \cot ;$ being the contact angle; contains the surface and interface energies; c involves the bulk stress in the island and the Poisson ratio and shear modulus of the substrate. It is clear from Eq.(1) that the surface energy dependent term prefers to have a large area island for stability. On the other hand the strain relaxation energy term prefers to have islands of sm aller area for greater stability. The optim all tradeo between surface energy and strain is obtained through the minimization of E/V with respect to s and t. This gives  $s = t = _o$ , where

$$_{o} = e h e^{-ch}$$
 (2)

For island sizes  $s;t < e_{o}$ , the square island shape (s = t) is stable. Once the island grows beyond its optimal diameter  $_{o}$  by a factor of e, the square shape becomes unstable and a transition to rectangular shape takes place. As the island grows, the aspect ratio t=s becomes ever larger.

The abovem entioned treatment was for epitaxial islands on a Si(100) surface which has a four-fold symmetry. In this case the island grow thup to the critical size has a four-fold symmetry (square). Beyond the critical size the islands grow in rectangular shape. The long rectangular islands have been called self-assembling quasi-one dimensional \quantum wires". In our case the substrate, Si(111), has three-fold symmetry. Therefore, the islands up to the critical size are of equilateral triangular shape and the shape transition is from triangle to trapezoid. Here in the initial stage of the growth the triangular islands are of submicron size and may be called self-assembling quasi-zero dimenional \quantum dots".

The thickness of the  $Au_4Si$  islands is 1 m, which is estimated from the penetration depth of 10 and 25 keV electrons used for the EPMA composition analysis. The tree-like structures in Fig. 1 consist of Au.

At this point let us try to make some quantitative estimates from the triangular and the trapezoidal islands observed in our experiments. Fig. 3(b) shows the plots of  $l_1$  and  $l_2$ 

versus island area A. It is seen that the islands grow as equilateral triangles  $(l_1 = l_2 = l_0)$ up to a critical size beyond which there is a transition to trapezoid  $(l_2 > l_1)$ . For the largest triangular islands the area is  $p \overline{3}l_0^2 = 4 = 110 \text{ m}^2$  (measured). In the light of Terso and Trom p theory, we attem pt to give an approximate estimation of the energy per unit volum e (E = V). We set the area of the island, where the shape transition takes place,  $e^2 = 110 \text{ m}^2$ . This provides  $_0 = 3.86 \text{ m}$ . W if h = 1 m and assuming  $= 45^\circ$ , we get = ch = 1.85. For the trapezoidal islands we use  $s = p \overline{3}l_1 = 2$  and  $t = l_2 = s p \overline{3}$  (A = st) and use Eq. (1) to evaluate E = V. For the triangular islands we use  $s = p \overline{3}l_1 = 2$  and  $t = l_2 = 2$  (A = st) to evaluate E = V. The results are shown in Fig. 3 (a) [22]. Our results are in reasonable agreement with the gross features of the Terso and Trom p theory. However, we do not observe the sharp change in the aspect ratio around the transition point as predicted by the theory. If the second derivative of the energy with respect to the island size is discontinuous asm entioned in Ref. [5], the magnitude of the discontinuity must be too sm all to be detected in the present experiment.

In the low energy electron m icroscopy (LEEM) study of gold silicide growth on S if111g for submonolayer Au deposition, M undschau et al. [8] observed triangular island growth for low coverages and rod shaped island growth at higher coverages with the major axis of these rods aligned along S i[110] directions. The rod-like islands had an aspect ratio of

8:1. However, in their study they found the elongated islands to be aligned along the three [110] directions on S if111g as expected from the symmetry. Our observation of unidirectional elongated island grow th along the [011] direction m ay be explained from the fact that our substrate surface was vicinal, i.e., the (111) surface was m isoriented by  $4^{\circ}$ towards [211] azim uthal direction. This m isorientation gives rise to the form ation of singlelayer and triple-layer steps which run along the [011] direction [23]. Thus our observed elongated islands are along the length of the steps. It is well known that nucleation and grow th are predom inant at surface defects. In our case the grow th m ight have occured preferentially at the steps. V icinal surfaces of sem iconductors are usually used as substrates for epitaxial overgrow th (such as directed epitaxy) and new interesting electronic properties of these systems have been predicted [24].

Rutherford backscattering of 2 M eV H e<sup>+</sup> ions from the sam ple provided evidence for the presence of a thin ( 50 A) layer containing gold even in the island-free region (the apparently depleted at region in Fig. 2). From EPM A analysis of this region we could not determ ine whether this Au exists as Au<sub>4</sub>S i, because the high energy electrons penetrate much deeper into the sam ple and leads to overestim ation of the S i content. For Au deposition (100-1000 A) on S i at room temperature, followed by annealing at T 400°C, and studied by other techniques, such as AES, a continuous silicide layer thickness of 30A was previously reported [25]. In our optical color m icrograph the at region and the islands appear to be of the sam e color which points to a composition of Au<sub>4</sub>S i for the at region as well. If this thin Au<sub>4</sub>S i layer is epitaxial, it would am ount to a layer-plus-island or Stranski-K rastanov grow th of Au<sub>4</sub>S i. The composition of the stringy structure in Fig. 2 as determ ined by EPM A is 100% Au.

The detailed features of the  $Au_4Si$  islands are not visible in the optical micrographs shown in Fig. 1 and Fig. 2. A scanning electron micrograph is shown in Fig. 4. The patterns with pin-hole structures on the islands indicate the presence of dislocations. In fact, in some cases we observed porous structure of the islands. Thus, in addition to the mechanism of shape transition for strain relief there is a partial strain relief through the form ation of dislocations in these strained epitaxial  $Au_4Si$  islands. As Terso and Trom p [5] point out, a partial strain relief through dislocations would not a left the general aspects of shape transition except for reducing the elective value of bulk stress of the island material. O ne would, of course, expect to see a larger critical size for islands with higher dislocation density. Thism ight be partly responsible for the large size (area 1000 times those observed in Ref.8) of the gold silicide islands on the brom ine-passivated Si(111) surface.

On the Si(111) substrates with a thin oxide layer we did not observe epitaxial island growth upon Au deposition and subsequent annealing at 360° C. It has been previously shown that the di usion behavior is di erent for a metal layer deposited on a brom inetreated Si(111) substrate and on an Si(111) substrate with a native oxide layer, the brom ine-

treated substrate behaving like an atom ically clean substrate and the native oxide acting as a di usion barrier at the interface [13].

In conclusion, growth of epitaxial structures of Au<sub>4</sub>Si has been observed in Au thin In sprepared by vacuum evaporation of Au on brom ine passivated Si(111) substrates and subsequent vacuum annealing at 360°C. These structures re ect the threefold symmetry of the underlying Si(111) substrate. The epitaxial structures are of equilateral triangle in shape. These epitaxial triangular islands grow bigger up to a certain critical size. Beyond the critical size the triangular structures undergo a shape transition to an elongated trapezoidal shape. All the elongated islands are aligned in the same direction, although one would expect them to grow in three di erent orientations in posed by the threefold symmetry of the Si(111) substrate surface. The threefold symmetry in the elongated island growth is apparently broken due to the vicinality of the substrate surface. We observed islands with aspect ratios as large as 8:1. How ever, under appropriate conditions, the islands may grow much longer in the preferential direction. In the scanning electron m icrograph of the islands, we found evidence for dislocations. This implies, both the strain relief mechanisms the shape transition and the form ation of dislocations are concommitant in the growth of A  $u_4$ S i islands on a brom ine-passivated Si(111) substrate. This may be, after all a general feature in the growth of strained epitaxial islands.

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#### FIGURES

FIG.1. Photom icrograph showing  $Au_4Si$  islands, that is, epitaxial  $Au_4Si$  crystallites on the Si(111) substrate. The three-fold symmetry is rejected in the shape of many islands. Smaller structures are formed for shorter duration of annealing. Diameter of the image is 400 m.

FIG.2. A  $u_4$ S i islands in the shape of trapezoid. A lthough the islands vary in length, their width rem ainspractically constant and approximately equal to that of the largest triangular islands. D iam eter of the image is 400 m.

FIG.3. (a) C om puted energy per unit volum e of island, in units of ch= o, vs m easured island area A ( - triangle, ?- trapezoid). The solid line is a polynom ial t. Beyond the transition point if the islands remained triangular the energy would be slightly (only 7% for the largest island) higher.

(b) Lengths  $l_1$  and  $l_2$  (as shown in the inset) of the islands, vs A. Unit of length for  $l_1$  and  $l_2$  is  $_{0}$  and that of A is  $_{0}^{2}$  [see text and Equ.(2)]. Solid lines are to guide the eye. For A <  $e^{2}$   $_{0}^{2}$ ,  $l_{1}$  and  $l_{2}$  are equal (equilateral triangle).

FIG.4. A scanning electron micrograph showing pin-hole patterns in the strained  $Au_4Si$  islands. The length of the middle island is 20 m.